

35.C15497



PATENT APPLICATION

#4
105
11/28/01
D. Belo

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
AKIHIRO KIMURA, ET AL.) Examiner: Not Yet Assigned
Application No.: 09/888,594) Group Art Unit: 2879
Filed: June 26, 2001)
For: ELECTRON SOURCE)
MANUFACTURING)
APPARATUS) September 10, 2001

Commissioner for Patents
Washington, D.C. 20231

SECOND INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The brief explanation of relevance for the non-English document may be found in the specification at page 1, line 14-22. Applicants note that in the Information Disclosure Statement filed August 14, 2001, a U.S. counterpart application, U.S. Patent No. 6,169,356 B1 was cited. Additionally, an English abstract for the cited Japanese reference is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Laura A. Palmer

Attorney for Applicants
Registration No. 29,767

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200